



SUPPLEMENTAL APPLICATION DATA SHEET

Application Information

Application Number:: 10/615,127
Filing Date:: 07/08/03
Subject Matter:: Utility
Title:: PROCESS FOR PREPARING A
STABILIZED IDEAL OXYGEN
PRECIPITATING SILICON WAFER
Attorney Docket Number:: MEMC TP-01-2450 (3009)
Total Drawing Sheets:: 4
Small Entity?:: No

Applicant Information

Applicant Authority Type:: Inventor
Primary Citizenship Country:: US
Status:: Full Capacity
Given Name:: Robert
Middle Initial:: J.
Family Name:: Falster
City of Residence:: London
State or Province of Residence:: England
Country of Residence:: United Kingdom
Street of Mailing Address:: 22 Compton Terrace
City of Mailing Address:: London
State or Province of Mailing
Address:: England
Postal Code of Mailing Address:: N1 2UN

Applicant Authority Type:: Inventor
Primary Citizenship Country:: Russia
Status:: Full Capacity
Given Name:: Vladimir

Middle Initial:: V.
Family Name:: Voronkov
City of Residence:: Merano
State or Province of Residence:: Bolzano
Country of Residence:: Italy
Street of Mailing Address:: Via Nazionale, 59
City of Mailing Address:: Merano
State or Province of Mailing
Address:: Bolzano
Postal Code of Mailing Address:: 39012

Correspondence Information

Correspondence Customer Number:: 000321

Representative Information

Representative Customer Number:: 000321

Assignee Information

Assignee Name:: MEMC Electronic Materials, Inc.